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Method of and apparatus for forming nozzles

Verfahren und Vorrichtung zum formen von Düsen

Procédé et appareil de façonnage de buses

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The present invention relates to methods and apparatus for forming a nozzle in a nozzle plate for an ink jet printhead, the nozzle having a nozzle inlet and a nozzle outlet in respective opposite faces of said nozzle plate.

WO93/15911 concerns methods of forming nozzles in a nozzle plate for an ink jet printhead utilising a high energy beam, in particular the ablation of nozzles in a polymer nozzle plate using an excimer laser. By means of a mask having a single aperture, a high energy beam is shaped prior to being directed by a converging lens onto the surface of a nozzle plate where a nozzle is formed.

WO93/15911 recommends increasing the divergence of the beam incident into the aperture of the mask by passing the beam through a layer such as a ground or etched surface or a thin film containing a medium having suitable light-scattering properties such as a colloid or opalescent material. Such a layer may be placed against a convergent lens which is itself located upstream of the mask for the purpose of focusing the beam into the aperture.

The divergence of the beam will determine the angle of taper of the nozzle. Furthermore, a second mask can be used to reduce the angle of divergence in one plane of the beam relative to another (both planes containing the beam axis), thereby to obtain a nozzle having a greater nozzle taper in one plane than in another. This will result in a nozzle inlet that is larger in one direction than in another direction perpendicular thereto - WO93/15911 points out that this advantageously allows the nozzle ink inlet to match the (generally rectangular) shape of an ink channel in the printhead with which the nozzle will communicate, whilst allowing the nozzle outlet to remain preferably circular.

The present invention has as its objective improvements to the processes described in the aforementioned WO93/15911, in particular to the manner in which the nozzle taper and the shape of the nozzle inlet and outlet are controlled.

GB 2,622,253 discloses a method of drilling air flow nozzles in aircraft wings, in which a laser beam is rotated about an axis to form a tapered nozzle.

According to a first aspect, the present invention consists in a method of forming a nozzle in a nozzle plate for an ink jet printhead, the nozzle having a nozzle inlet and a nozzle outlet in respective opposite faces of said nozzle plate, characterised by the steps of:

1. Directing a high energy beam having a first axis extending in a first direction towards said nozzle plate;
2. Directing said beam at a first reflecting surface lying at an angle to said first direction, said surface being arranged so as to reflect said beam towards a second reflecting surface and a third reflecting surface so arranged as to both invert said beam and direct said beam along said beam along an axis collinear and third with said first axis extending in a first direction; said first, second and third surfaces being fixedly located relative to one another to form an assembly; and rotating said assembly about said first axis; said beam impinging on said nozzle plate, thereby to form a nozzle.

As explained in greater detail in the description that follows, this technique results in a high energy beam having a uniform intensity at a given radius and, when applied to the manufacture of nozzles, yields nozzle dimensions lying within tighter tolerance bands and consequently a better quality nozzle.

Preferred arrangements of the present invention include the step of introducing divergence into said beam by splitting said beam into a number of sub-beams, each sub-beam having divergence, the origin of divergence of each sub-beam lying apart from the point at which the respective sub-beam is created by splitting, the sub-beams thereafter being passed through further beam converging means prior to being recombined. This arrangement allows substantially more accurate control of the angle of divergence of the beam than has been possible in prior art arrangements: as mentioned, WO93/15911 proposes increasing the divergence of the high energy beam by scattering the light using a ground or etched surface or a thin film containing a medium having suitable light-scattering properties. It has been recognised in the present invention that divergence can be obtained in a much more controlled manner by splitting the high energy beam into a number of sub-beams which are subsequently recombined. Furthermore, the beam is split such that each sub-beam has divergence having an origin at a point lying apart from the point at which the respective sub-beam is created by splitting. It will be appreciated that the divergence obtained in this manner - which may be achieved using a lens to create each sub-beam - will be subject to substantially less variation than is achieved using prior art methods based on scattering. It follows that less variation in the angle of divergence of the combined beam will result in less variation in the angle of taper of the manufactured nozzles - resulting in better ink ejection performance of the final inkjet printhead.

Furthermore, by directing the recombed beam through a single aperture of a mask, with the dimensions of the section of the recombed beam directly prior to impinging the plane of said mask being substantially equal to the dimensions of the aperture in said mask, the high energy beam that finally impinges on the nozzle plate to form a nozzle does not have its divergence reduced by any significant amount by the mask. Consequently, the full range of beam divergence is available to form nozzle bores having a correspondingly high taper angle from outlet to inlet.

In addition, the high energy beam is directed at the nozzle plate by means of first and second reflecting means and the optical elements in said array - e.g. lenses
A particular example of the present invention again share the concept of splitting a high energy beam into sub-beams having an origin of divergence lying apart from the plane of beam splitting and thereafter recombining the sub-beams through beam converging means, and also comprises an array of optical elements having a greater width in a first direction than in a second direction orthogonal to said first direction, which allows the production in a simple and accurate manner of nozzles having a greater taper angle in one direction than in another. This in turn yields a nozzle inlet having a greater dimension in one direction than in the direction orthogonal thereto, such a configuration may be particularly desirable where the ink supply channel through which the nozzle is attached is also non-axi-symmetric.

A method of forming a nozzle in a nozzle plate for an inkjet printhead, the nozzle having a nozzle inlet and a nozzle outlet in respective opposite faces of the nozzle plate according to another example of the invention includes the step of directing a high energy beam at the face of the nozzle plate in which said nozzle outlet is to be formed, whereby the power of said high energy beam is initially held low and is increased with increasing depth of the nozzle formed in said nozzle plate. As is also explained in greater detail in the description hereafter, this technique gives a higher quality nozzle outlet, better internal finish and a more accurate nozzle shape.

The present invention also comprises apparatus for carrying out the methods outlined above.

The invention will now be described by way of example by reference to the following diagrams, of which:

Figure 1 is a schematic illustration of a first embodiment of apparatus for use with the present invention when viewed in a direction X;
Figure 2 is a view of the apparatus of Figure 1 in a direction Y orthogonal to direction X;
Figure 3 is a further example;
Figure 4a is a perspective view of yet another example;
Figure 4b is a sectional view through the mirror arrangement 82, 84 of Figure 4a;
Figure 5a is a sectional view through a beam conditioning device according to the present invention;
Figure 5b is a schematic diagram of the beam section following conditioning;
Figures 6a and 6b illustrate the functioning of the device of Figure 5a at rotation angles of 0° and 90° respectively.

Figure 1 shows an embodiment of apparatus for use in carrying out the method according to one aspect of the present invention. Reference 20 designates a nozzle plate in which a nozzle is to be formed. The apparatus 10 comprises a source of a high energy beam such as a UV excimer laser (not shown) which generates a high energy beam 30 which, after having undergone various beam conditioning processes (e.g. collimating, shaping of the beam to fit further optical devices located "downstream"), is directed at an array 40 of optical elements which, in the present example, are cylindrical lenses 45. Such an array of lenses is commonly known as a flyeye lens.

The array 40 splits the beam into a corresponding array of sub-beams 50, each sub-beam having a focal point 52. As will be clear from the figure, after passing through the focal point 52, each sub-beam will be divergent with a divergence angle (Aa, Ab in Figure 1) and an origin of divergence at the focal point 52 of the respective lens 45 (note that for the sake of clarity, only outlines of those beams issuing from the outermost lenses of the array 40 have been shown; the beams from lenses nearer the center of the array will fall within these extremes). It will be appreciated that range Aa, Ab of angles of divergence of each sub-beam emanating from the lenses 45 will be much narrower than the range that would be expected from prior art techniques utilising scattering. As shown in Figure 1, the array of sub-beams issuing from the array 40 is passed through a converging lens 60, thereby to recombine the sub-beams at 56.

The recombined beam is directed at the aperture 72 of a mask 70, and to this end, the mask is preferably located at a distance from the lens 60 equal to the focal length of the lens.

Although in the example shown the focal point of the sub-beams 52 is located downstream of the array 40, any arrangement where the focal point of the sub-beams is located before the subsequent mask 70 will suffice; the lenses in the array 40 may for example diverge the incoming beam such that the origin of divergence is located "upstream" of the array 40, for example. The strength of the subsequent converging lens 60 may be chosen such that the sub-beams still recombine.

As mentioned above and shown in Figures 1-3, the dimensions of the section of the recombed beam directly prior to impinging the plane of the mask are substantially equal to the dimensions of the aperture in said mask. The recombed beam passing through the aperture (and indicated by 74 in Figure 1) is subsequently guided by means of a further convergent lens 80 onto the surface 22 of the nozzle plate 20 where it ablates the material of the nozzle plate, thereby forming a nozzle. The strength of the lens 80 and the relative positions of the nozzle plate 20 and mask 70 are chosen such that an image of the mask aperture 72, illuminated by the beam 56, is projected onto the surface 22 of the nozzle plate. The nozzle section at the surface 22 and the mask aperture 72 can be seen to be conjugate through the lens.
0 and consequently, by changing the size of the aperture 72 the size of the hole formed in the surface 22 (which forms the outlet orifice of the resulting nozzle) can be altered.

[0021] As is evident from the figure, the sub-beams 74a, 74b making up beam 74 strike the surface 22 of the nozzle plate at an angle, with the result that the section of the hole ablated by the beams increases with the depth of the ablated hole. The resulting nozzle is therefore tapered, with the nozzle section at the "front" surface 22 of the nozzle plate 20 being determined by the mask aperture 72 and the section at the "rear" surface 24 being determined by both the aperture 72 and the angle of the incident beams.

[0022] The angle of the incident beams is determined both by the strength of the lens 80 and by the angles of divergence present in the beam 74 passing through the aperture 72. The former preferably lies in the range: 0.4 ≤ aperture ≤ 0.65 (corresponding to magnification of x25 and x52 respectively). The latter is determined by the strength of the lenses in the array 40 and also the geometry of the array. As already mentioned, the features whereby divergence is introduced into the beam by splitting it into a number of sub-beams, each sub-beam having divergence, allows the angle of divergence of the nozzle forming beam to be controlled that much more accurately. This in turn allows accurate control of the three-dimensional shape of the resulting nozzle, in particular its taper angle and the sections at the nozzle outlet and inlet.

[0023] Ensuring that the dimensions of the section of the recombinated beam directly prior to impinging the plane of the mask are substantially equal to the dimensions of the aperture in the mask, as mentioned above, ensures that the high energy beam that finally impinges on the nozzle plate to form a nozzle does not suffer any significant reduction in its divergence - which might result in a corresponding reduction in nozzle taper. In practice, the section of the recombinated beam will have slightly greater dimensions than the mask aperture: were the recombinated beam to be smaller than the mask aperture, then the mask would no longer play any masking function and the image projected onto the front of the nozzle plate being not that of the aperture but that of the flyseye lens. It will also be evident from Figure 1 that the matching between the dimensions of the aperture and the recombinated beam also means that the divergence angles (Ba, Bb in Figure 1) of the sub-beams 74a, 74b making up the recombinated beam 74 at a position downstream of the mask 70 correspond to the divergence angles Aa and Ab of the sub-beams 50 upstream of the mask.

[0024] Figure 2 is a view in a direction Y orthogonal to the direction of viewing X of Figure 1 and illustrates the case where the array 40 has a rectangular geometry, being wider in the X direction than in the Y direction. It can be seen that the angle of divergence of the beams leaving the aperture 72 is correspondingly greater than that shown in Figure 1, as is the angle of taper of the nozzle in this direction and thus the dimension of the nozzle at the "rear" surface of the nozzle plate (indicated by x2 in Figure 2 and greater than distance x1 in Figure 1). The overall shape of the nozzle at the rear surface will be rectangular, in correspondence with the geometry of the array 40.

[0025] It should be noted that geometry of the array 40 can be altered either by rearranging the location of the lenses in the array or by blocking out some of the lenses of an existing array e.g. by means of a mask placed directly upstream of the array.

[0026] The individual lenses making up the array 40 each contribute a bundle of diverging beams, each bundle having a section which may be circular or some other shape depending whether the optical elements making up the array are lenses, prisms or otherwise having axisymmetric or some other shape respectively. Whilst this feature is instrumental in obtaining many of the advantages described in the present application, it nevertheless results in the aforementioned section of the nozzle at the "rear" surface 24 having a corrugated outline. However, where this "rear" section is circular, the corrugations can be avoided by rotating the flyseye lens about its polar axis during the course of the nozzle forming process.

[0027] An alternative method of influencing the angle of the incident beams to control nozzle taper is to interpose a further mask between the mask 70 and the lens 80. Such an arrangement is illustrated in Figure 3, the further mask being designated by reference figure 110, the corresponding aperture by 112. It is evident that the mask 110 blocks out those beams passing through the aperture 72 which have divergence greater than a certain angle, resulting in a nozzle with reduced inlet size x3. The dimensions and shape of the further aperture can be varied to control the dimensions and shape of the shape of the nozzle at the rear surface, as is known from the aforementioned WO-A-93/15911.

[0028] Advantageously, a further converging ("field") lens can be located directly upstream of the mask aperture 72, as indicated by reference figure 76 in Figure 3. Movement of this lens in its own plane, i.e. parallel to the mask 70, allows the combined diverging sub-beams to be aligned with the mask aperture. Nonalignment results in one side of the beam being obscured more than another which in turn results in one side of the nozzle having a lesser taper than the other. Such asymmetry is undesirable in a nozzle.

[0029] According to another preferred embodiment of the invention, there is located upstream of the flyseye lens a variable beam attenuator (not shown in the figures). Such devices are generally known in the art and for this reason their construction will not be discussed here in any detail. In the present invention, however, such a device is advantageously employed to control the power of the high energy beam during the nozzle formation process: at the beginning of the nozzle formation process, laser power is held low to minimise damage to the nozzle outlet from exhaust products of the ablation proc-
Power is then increased as the depth (and section) of the forming nozzle increases. Towards the end of nozzle formation, high laser power is employed to give the nozzle a good internal finish and to ensure faithful reproduction of the shape of the nozzle forming beam. The initial rate of increase of laser power is preferably low, even zero, increasing once the forming nozzle has attained a certain depth. Measurement of the depth of the forming nozzle is not necessary: the power of the laser may be controlled as a function of time, the time necessary for a given process to reach a certain depth being determinable by experiment.

It will be apparent that many kinds of lens may be used for the convergent lenses 60, 74 and 80 referred to above. However, it has been found particularly advantageous to use for the lens 80 a lens comprising two mirrors of the type generally known as a Cassegrain reflective lens. An example is shown schematically in Figure 4a, the mask 70 and convergent lens 60 having been omitted for the sake of clarity. Figure 4b shows the mirrors 82, 84 in section, from which it is clear that the mirrors are axi-symmetric, having reflective surfaces that are surfaces of revolution. Such a lens arrangement has a high magnification (equivalent to a high numerical aperture value), allowing a high degree of angling of the incident beams relative to the axis of the lens (equivalent to a lower angle of incidence between beam and the surface 22 of the nozzle plate 20) and the formation of nozzles of significant taper. Such lenses also exhibit low aberration since the beam does not pass through any lens material but is simply reflected from one surface to another. Finally, it will be appreciated from Figure 4 that the reflecting surfaces of such an arrangement are generally located away from the surface of the nozzle plate and are thus less likely to be contaminated by debris generated during the nozzle formation process.

The flyseye lens may advantageously be adapted for use with a lens of the type described above by rendering the central lenses of the array inoperative e.g. by removing the lenses or blocking them out as shown in Figure 4. Blocking may be achieved by means of a mask located directly upstream or downstream. The sub-beams from these central lenses might otherwise reflect back into and damage optical elements (even the laser) located upstream. In the embodiment shown, utilising an 6 x 6 array of lenses, the centre four lenses of the array are masked out.

Figure 5a shows apparatus that is particularly suited for use in the manufacture of nozzles for inkjet printheads and in particular for use with arrangements described above. Located upstream of the flyseye lens, the device 120 comprises an assembly of three reflecting surfaces 121, 122, 123 held fixed relative to one another by means of a housing 124, the assembly being rotatable together about an axis 125, for example in bearings 126 by means of a motor (not shown). The incoming beam 30 is directed along the axis 125, strikes surface 121 and is reflected to surface 122 and back to surface 123 whence it leaves the device, again along the axis 125. In the example shown, the reflecting surfaces 121,122,123 are high reflectance dielectric mirrors.

It will therefore be evident that apparatus located downstream of the rotating device 120 described above will be exposed to a beam 30' having an intensity at a given point P at a radius r from the beam axis that varies at a frequency corresponding to twice the angular velocity of the housing 124 (see Figure 5b). The incoming beam 30 to be totally homogeneous, at least at a given radius r from the beam axis, the point P would experience no change in beam intensity. In practice, however, the beam 30 generated by the laser is not homogeneous, even at a given radius, with the result that the point P will experience a periodically varying beam intensity. Such a varying intensity does nevertheless have the virtue of having the same average value for all points irradiated by the beam which are located at a radius r from the beam axis. Since beam intensity at a point translates into rate of material removal at the nozzle plate, use of the device described above results in nozzles that are more uniform (at least at a given nozzle radius) than would be obtained using a beam not subject to such conditioning.

The use of discrete reflecting surfaces 121, 122 and 123 is particularly appropriate in a device employing a high energy beam: these have the advantage of low aberration when used with high energy beams, as well having lower losses and being more robust than conventional lenses/prisms. In the example shown above, high reflectance dielectric mirrors are used.

It should be noted that other types of beam homogeniser, as are well known in the art, may be used in place of/in addition to the beam conditioning device just described.

A further imperfection in real-life optic systems is the presence of stray beams caused by imperfections in the optical elements making up the system: such stray beams, if allowed to hit the nozzle plate, may result in a nozzle that deviates from the ideal. This can be avoided by the use of a spatial filter, shown by way of example in Figure 3, and comprising a mask 130 placed just in front of beam 30.
of the nozzle plate at the point where the beams cross prior to impinging on the nozzle plate. The aperture in the mask is chosen to pass the nozzle-forming beam yet exclude any stray beams failing outside of the nozzle-forming beam. The accuracy of the aperture is therefore crucial. Advantageously, the aperture can be formed by the insitu ablation of a mask blank using the same beam and optics subsequently used for nozzle ablation. The material of the mask blank should of course be chosen such that, unlike the nozzle plate material, it does not ablate significantly under the action of stray beams.

[0038] A further process step for increasing the quality of the manufactured nozzles is to carry out the ablation process in an atmosphere of Helium or Oxygen. Accordingly, the nozzle plate is placed in a chamber supplied with the appropriate gas and having a window through which the beam is transmitted. Components such as the spatial filter which lie very close to the nozzle plate may also be accommodated in the chamber. Helium used in the chamber acts as a cooling medium, condensing the ablation products before they have the opportunity to damage any other part of the nozzle plate, whilst oxygen used in the chamber reacts with the ablation products, turning them to gas. Both methods result in a cleaner end product

[0039] The present application is directed in the main to methods of manufacturing nozzles in a nozzle plate of an inkjet printhead. Although only a single nozzle is shown in the figures, most designs of printhead will have a substantial number of nozzles e.g. 64 or 128. Manufacturing time can obviously be reduced by forming more that one nozzle at a time, these being either nozzles in the same printhead or nozzles belonging to separate prinheads. However, full optical systems of the type shown in Figures 1 and 2 are not necessarily required for each nozzle to be formed simultaneously: for example, the beam from a single high energy beam source may be used to feed a number of individual optical systems. Furthermore, only a single variable beam attenuator is necessary if it used to control the power of the single beam prior to splitting. Alternatively, the beam splitting optics may be inserted between the mask 70 and the convergent lens 80, thus reducing duplication to the convergent lens 80 and any other elements (spatial filter etc.) that might be required downstream thereof.

[0040] As regards the printhead itself, the nozzle plate 22 is made of a material, e.g. polystyrene, polycarbonate, polyester, polystyrene/PC or acrylic, that will ablate when irradiated by light from a UV excimer laser. Whilst the process of ablation - which is well known in the context of inkjet printheads as being capable of forming accurate nozzles - is to be preferred, the present invention is not intended to be restricted to this type of high energy beam. Radiation from other types of laser or other sources may be employed as a high energy beam.

[0041] It will be appreciated from the foregoing description that the present invention is particularly suited to forming tapered nozzles. In use, the broad section of the tapered nozzle serves as the nozzle ink inlet and is connected to an ink channel of the printhead whilst the narrow section of the nozzle serves as the droplet ejection outlet. The Ofront surface of the nozzle plate in which the outlet is formed may have a low energy, non-wetting coating to prevent ink build-up around the nozzles. In the case where this coating is applied to the nozzle plate before nozzle formation, the beam must break through this coating as well as the nozzle plate material.

[0042] Nozzles may be formed in the nozzle plate either before or after attachment of the nozzle plate to the printhead (as is known in the art, see for example the aforementioned WO93/15911). In both cases, the location of the nozzle relative to the respective channel is important and is facilitated by means for manipulating the nozzle plate/printhead relative to the optical system prior to nozzle formation.

Claims

1. Method of forming a nozzle in a nozzle plate for an inkjet printhead, the nozzle having a nozzle inlet and a nozzle outlet in respective opposite faces of said nozzle plate, characterised by the steps of:

   directing a high energy beam having a first axis extending in a first direction towards said nozzle plate;
   directing said beam at a first reflecting surface lying at an angle to said first direction, said surface being arranged so as to reflect said beam towards a second reflecting surface and a third reflecting surface so arranged as to both invert said beam and direct said beam along an axis collinear with said first axis extending in a first direction; said first, second and third surfaces being fixedly located relative to one another to form an assembly; and
   rotating said assembly about said first axis; said beam impinging on said nozzle plate, thereby to form a nozzle.

2. Method according to claim 1 wherein the reflecting surfaces each comprises a discrete member.

3. Method according to claim 2, wherein said discrete member is a high reflectance dielectric mirror.

4. Method according to any one of claims 1 to 3, further comprising the steps of:

   introducing divergence into said beam; thereafter directing said beam at a single aperture of a mask, thereby to shape said beam; and thereafter passing said beam through beam converging means prior to impingement on the face of said nozzle plate in which said nozzle outlet is
5. Method according to Claim 4, wherein the step of introducing divergence into said beam comprises splitting said beam into a number of sub-beams, each sub-beam having divergence, the origin of divergence of each sub-beam lying apart from the point at which the respective sub-beam is created by splitting; the sub-beams thereafter being passed through further beam converging means prior to being recombined and directed through said single aperture of a mask, wherein the dimensions of the section of said recombined beam directly prior to impinging the plane of said mask are substantially equal to the dimensions of the aperture in said mask.

6. Method according to claim 5, wherein the step of splitting the beam into a number of sub-beams comprises passing said beam through an array of lenses.

7. Method according to claim 6, wherein said array comprises cylindrical lenses.

8. Method according to any one of claims 5 to 7, wherein the origin of divergence of each sub-beam lies ahead of said mask.

9. Method according to claim 8, wherein the origin of divergence of each sub-beam lies between the point at which the respective sub-beam is created by splitting and said mask.

10. Method according to any one of claims 5 to 9, wherein said mask is located at a distance from said further beam converging means equal to the focal length of said further beam converging means.

11. Method according to any one of claims 1 to 3, wherein said beam is split by passage through an array of optical elements to create an array of sub-beams; said array of sub-beams being thereafter directed towards said first reflecting surface the arrangement of said optical elements being such that all incoming sub-beams are directed by said first reflecting surface towards said second and third reflecting surfaces, thereafter to impinge on said nozzle plate.

12. Method according to any preceding claim, wherein said high energy beam is split by passage through an array of optical elements to create an array of sub-beams, said array of optical elements having a greater width in a first direction than in a second direction orthogonal to said first direction, with said first and second directions lying perpendicular to the direction of impingement of said beam on said array; thereby to form a nozzle having a bore with an angle of taper relative to the nozzle axis in a direction corresponding to said first direction that is greater than the angle of taper of the nozzle bore in a direction corresponding to said second direction.

13. Method according to any preceding claim, wherein the power of said high energy beam is initially held low and is increased with increasing depth of the nozzle formed in said nozzle plate.

14. Apparatus for use with the method of any one of the preceding claims, and comprising a source of a high energy beam having a first axis extending in a first direction; an assembly comprising a first reflecting surface lying at an angle to said first direction, a second reflecting surface and a third reflecting surface, said first, second and third reflecting surfaces being fixedly located relative to one another such that said high energy beam is reflected by said first reflecting surface onwards said second reflecting surface and said third reflecting surface, thereby to both invert said beam and direct said beam along an axis collinear with said first axis extending in a first direction; said assembly being rotatable about said first axis.

15. A system for forming a nozzle in a nozzle plate for an ink jet printhead, said system comprising a nozzle plate substrate, an assembly, and a source of a high energy beam having a first axis extending in a first direction; wherein the assembly comprises a first reflecting surface lying at an angle to said first direction, a second reflecting surface, and a third reflecting surface, said first, second, and third reflecting surfaces being fixedly located relative to one another such that said high energy beam is reflected by said first reflecting surface towards said second reflecting surface and said third reflecting surface, thereby to both invert said beam and direct said beam along a second axis collinear with said first axis extending in the first direction; said assembly being rotatable about said first axis, and said nozzle plate substrate being partly disposed within a path defined by said second axis and arranged such that said beam is directed at and first impinges upon a face of said nozzle plate substrate in which a nozzle outlet is formed, and wherein said nozzle outlet is smaller in size than a nozzle inlet formed in an opposite face of said nozzle plate substrate.

1. Verfahren zum Ausbilden einer Düse in einer Düsenplatte für einen Tintenstrahl-Druckkopf, wobei die Düse einen Düsenaustritt und einen Düsenaustritt in entsprechenden gegenüberliegenden Flächen der Düsenplatte besitzt, gekennzeichnet durch die folgenden Schritte:
Richten eines Hochenergiestrahls mit einer ersten Achse, die sich in einer ersten Richtung erstreckt, zu der Düsenplatte; Richten des Strahls auf eine erste reflektierende Oberfläche, die unter einem Winkel zu der ersten Richtung orientiert ist, wobei die Oberfläche so beschaffen ist, dass sie den Strahl zu einer zweiten reflektierenden Oberfläche und zu einer dritten reflektierenden Oberfläche reflektiert, die so angeordnet sind, dass sie den Strahl sowohl umkehren als auch längs einer Achse ausrichten, die zu der ersten Achse, die sich in einer ersten Richtung erstreckt, kollinear ist; wobei die erste, die zweite und die dritte Oberfläche relativ zueinander fixiert sind, um eine Baugruppe zu bilden; und Drehen der Baugruppe um die erste Achse; wobei der Strahl auf die Düsenplatte auftrifft, worauf eine Düse gebildet wird.

2. Verfahren nach Anspruch 1, bei dem die reflektierenden Oberflächen jeweils ein diskretes Element umfasst.


4. Verfahren nach einem der Ansprüche 1 bis 3, das ferner die folgenden Schritte umfasst:

   a) Einführen einer Divergenz in den Strahl; danach Richten des Strahls auf eine einzige Blende einer Maske, um dadurch den Strahl zu formen; und danach Schicken des Strahls durch Strahlkonvergenzmittel, bevor er auf der Fläche der Düsenplatte auftrifft, in der der Düsenaußendurchmesser gebildet wird, worauf eine Düse gebildet wird, wobei der Düsenaußendurchmesser durch die Strahlkonvergenzmittel der einzigen Blende zugeordnet ist.

5. Verfahren nach Anspruch 4, bei dem der Schritt des Einführens einer Divergenz in den Strahl das Teilen des Strahls in zahlreiche Unterstrahlen umfasst, wobei jeder Unterstrahl eine Divergenz aufweist, wobei der Ausgangspunkt der Divergenz jedes Unterstrahls in einem Abstand von dem Punkt liegt, an dem der jeweilige Unterstrahl durch Teilung erzeugt wird; wobei die Unterstrahlen danach durch weitere Strahlkonvergenzmittel geschickt werden, bevor sie rekombiniert und durch eine einzige Blende einer Maske gelenkt werden, wobei die Abmessungen des Querschnitts des rekombinierten Strahls direkt vor dem Auftreffen auf die Ebene der Maske im Wesentlichen gleich den Abmessungen der Blende in der Maske sind.


7. Verfahren nach Anspruch 6, bei dem die Anordnung zylindernder Linsen umfasst.

8. Verfahren nach einem der Ansprüche 5 bis 7, bei dem der Ausgangspunkt der Divergenz jedes Unterstrahls vor der Maske liegt.


10. Verfahren nach einem der Ansprüche 5 bis 9, bei dem die Maske sich in einem Abstand von den weiteren Strahlkonvergenzmitteln befindet, der gleich der Brennweite der weiteren Strahlkonvergenzmittel ist.

11. Verfahren nach einem der Ansprüche 1 bis 3, bei dem der Strahl durch seinen Durchgang durch eine Anordnung optischer Elemente geteilt wird, um eine Anordnung von Unterstrahlen zu erzeugen; wobei die Anordnung von Unterstrahlen danach zu der ersten reflektierenden Oberfläche gerichtet wird, wobei die Anordnung der optischen Elemente derart ist, dass alle ankommenden Unterstrahlen durch die erste reflektierende Oberfläche zu der zweiten und der dritten reflektierenden Oberfläche gerichtet werden, um danach auf der Düsenplatte aufzutreffen.

12. Verfahren nach einem vorhergehenden Anspruch, bei dem der Hochenergiestrahl durch seinen Durchgang durch eine Anordnung optischer Elemente geteilt wird, um eine Anordnung von Unterstrahlen zu erzeugen, wobei die Anordnung optischer Elemente in einer ersten Richtung eine größere Breite als in einer zu der ersten Richtung senkrechten zweiten Richtung besitzt, wobei die erste und die zweite Richtung der Anordnung, in der der Strahl auf der Düsenachse in einer der zweiten Richtung entsprechenden Richtung liegt, wobei eine Düsenachse in einer der ersten Richtung entsprechenden Richtung geben wird, wobei die Düsenachse einer der ersten Richtung entsprechenden Richtung zugeordnet ist.

13. Verfahren nach einem vorhergehenden Anspruch, bei dem die Leistung des Hochenergiestrahls anfangs niedrig gehalten wird und mit zunehmender Tiefe der in der Düsenplatte ausgebildeten Düse erhöht wird.
14. Vorrichtung für die Verwendung mit dem Verfahren nach einem der vorhergehenden Ansprüche, die umfasst: eine Quelle für einen Hochenergiestrahl, der eine erste Achse besitzt, die sich in einer ersten Richtung erstreckt; eine Baugruppe, die eine erste reflektierende Oberfläche, die unter einem Winkel zu der ersten Richtung orientiert ist, eine zweite reflektierende Oberfläche und eine dritte reflektierende Oberfläche aufweist, wobei die erste, die zweite und die dritte reflektierende Oberfläche relativ zueinander fixiert sind, so dass der Hochenergiestrahl durch die erste reflektierende Oberfläche auf die zweite reflektierende Oberfläche und auf die dritte reflektierende Oberfläche reflektiert wird, wodurch der Strahl sowohl umgekehrt als auch auf eine Achse, die zu der in einer ersten Richtung sich erstreckenden ersten Achse kollinear ist, ausgerichtet wird; wobei die Baugruppe um die erste Achse drehbar ist.

15. System zum Bilden einer Düse in einer Düsenplatte für einen Tintenstrahl-Druckkopf, wobei das System umfasst: ein Düsenplattensubstrat, eine Baugruppe und eine Quelle für einen Hochenergiestrahl, der eine erste Achse besitzt, die sich in einer ersten Richtung erstreckt; wobei die Baugruppe eine erste reflektierende Oberfläche, die unter einem Winkel zu der ersten Richtung orientiert ist, eine zweite reflektierende Oberfläche und eine dritte reflektierende Oberfläche besitzt, wobei die erste, die zweite und die dritte reflektierende Oberfläche relativ zueinander fixiert sind, derart, dass der Hochenergiestrahl durch die erste reflektierende Oberfläche zu der zweiten reflektierenden Oberfläche und zu der dritten reflektierenden Oberfläche reflektiert wird, wodurch der Strahl sowohl umgekehrt wird als auch entlang einer zweiten Achse, die zu der in der ersten Richtung sich erstreckenden ersten Achse kollinear ist, ausgerichtet wird; wobei die Baugruppe um die erste Achse drehbar ist und wobei das Düsenplattensubstrat teilweise in einem Weg angeordnet ist, der durch die zweite Achse definiert und derart be- schaffen ist, dass der Strahl auf jene Fläche des Düsenplattensubstrats, in der ein Düsenauslass gebildet ist, gerichtet wird und als Erstes auf ihr auftrifft, wobei der Düsenauslass eine geringere Größe be- sitzt als der in einer gegenüberliegenden Fläche des Düsenplattensubstrats ausgebildete Düsenleisten.

Revendications

1. Procédé de façonnage d’une buse en une plaque de buse pour une tête d’impression à jet d’encre, la buse ayant une entrée de buse et une sortie de buse sur des faces opposées respectives de la plaque de buse, caractérisé par les étapes consistant à:

- diriger un faisceau haute énergie comportant un premier axe s’étendant dans une première direction vers ladite plaque de buse;
- diriger ledit faisceau vers une première surface de réflexion faisant un angle avec ladite première direction, ladite surface étant disposée de façon à réfléchir ledit faisceau vers une deuxième surface de réflexion et une troisième surface de réflexion disposées de façon à, en même temps, inverser ledit faisceau et diriger ledit faisceau le long d’un axe colinéaire avec ledit premier axe s’étendant dans une première direction ; lesdites première, deuxième et troisième surfaces étant placées de façon fixe l’une par rapport à l’autre, de façon à former un ensemble, et faire tourner ledit ensemble autour dudit premier axe; ledit faisceau frappant sur ladite plaque de buse, formant ainsi une buse.

2. Procédé selon la revendication 1, dans lequel les surfaces de réflexion comprennent chacune un élément discret.

3. Procédé selon la revendication 2, dans lequel ledit élément discret est un miroir diélectrique haute réflectance.

4. Procédé selon l’une quelconque des revendications 1 à 3, comprenant en outre les étapes consistant à:

- introduire une divergence dans ledit faisceau ;
- en dirigeant ensuite ledit faisceau vers une ouverture simple d’un masque, formant ainsi ledit faisceau ; et à faire passer ensuite ledit faisceau au travers de moyens de convergence de faisceau avant qu’il ne vienne frapper la face de ladite plaque de buse dans laquelle ladite ouverture de buse est façonnée, formant ainsi une buse, la sortie de buse étant conjuguée au travers desdits moyens de convergence de faisceau avec ladite ouverture simple.

5. Procédé selon la revendication 4, dans lequel l’étape consistant à introduire une divergence dans ledit faisceau comprend le partage dut faisceau en un certain nombre de sous-faisceaux, chaque sous-faisceau ayant une divergence, l’origine de la divergence de chaque sous-faisceau se trouvant à l’écart du point auquel le sous-faisceau respectif est créé par partage ; les sous-faisceaux étant ensuite aménés à passer au travers des moyens ultérieurs de convergence de faisceau avant d’être recombinés et dirigés au travers de ladite ouverture simple d’un masque, dans lequel les dimensions de la section dudit faisceau recombiné directement avant de venir frapper sur le plan dudit masque sont sensiblement égales aux dimensions de l’ouverture dans ledit masque.
6. Procédé selon la revendication 5, dans lequel l’étape de partage du faisceau en un certain nombre de sous-faisceaux comprend l’étape consistant à faire passer ledit faisceau au travers d’une matrice de lentilles.

7. Procédé selon la revendication 6, dans lequel ledit tableau comprend des lentilles cylindriques.

8. Procédé selon l’une quelconque des revendications 5 à 7, dans lequel l’origine de la divergence de chaque sous-faisceau se trouve devant ledit masque.

9. Procédé selon la revendication 8, dans lequel l’origine de la divergence de chaque sous-faisceau se trouve entre le point auquel ledit sous-faisceau respectif est créé par partage et ledit masque.

10. Procédé selon l’une quelconque des revendications 5 à 9, dans lequel ledit masque se trouve à une distance des autres moyens de convergence ultérieure de faisceau égale à la longueur focale desdits moyens de convergence ultérieure de faisceau.

11. Procédé selon l’une quelconque des revendications 1 à 3, dans lequel ledit faisceau est partagé par le passage au travers d’une matrice d’éléments optiques pour créer une matrice de sous-faisceaux ; ladite matrice de sous-faisceaux étant ensuite dirigée vers ladite première surface de réflexion, la disposition desdits éléments optiques étant telle que tous les sous-faisceaux entrants sont dirigés par ladite première surface de réflexion vers lesdites deuxième et troisième surfaces de réflexion, pour frapper ensuite ladite plaque de buse.

12. Procédé selon l’une quelconque des revendications précédentes, dans lequel ledit faisceau haute énergie est partagé par le passage au travers d’une matrice d’éléments optiques pour créer une matrice de sous-faisceaux, ladite matrice d’éléments optiques ayant une largeur plus grande dans une première direction que dans une seconde direction orthogonale à ladite première direction, lesdites première et seconde directions étant perpendiculaires à la direction d’incidence dudit faisceau sur ladite matrice ; pour former ainsi une buse ayant un alésage présentant un angle d’inclinaison par rapport à l’axe de la buse dans une direction correspondant à ladite première direction qui est supérieur à l’angle d’inclinaison de l’alésage de buse dans une direction correspondant à ladite seconde direction.

13. Procédé selon l’une quelconque des revendications précédentes, dans lequel la puissance dudit faisceau haute énergie est initialement maintenue à une valeur faible et est augmentée avec la profondeur croissante de la buse formée dans ladite plaque de buse.

14. Appareil destiné à un usage avec le procédé selon l’une quelconque des revendications précédentes, et comprenant une source d’un faisceau haute énergie comportant un premier axe s’étendant dans une première direction ; un ensemble comprenant une première surface de réflexion faisant un angle avec ladite première direction, une deuxième surface de réflexion et une troisième surface de réflexion, lesdites première, deuxième et troisième surfaces de réflexion étant placées de façon fixe l’une par rapport à l’autre de telle sorte que ledit faisceau haute énergie est réfléchi par ladite première surface de réflexion vers ladite deuxième surface de réflexion et ladite troisième surface de réflexion, de façon à, en même temps, inverser ledit faisceau et à diriger ledit faisceau le long d’un axe colinéaire avec ledit premier axe s’étendant dans une première direction ; ledit ensemble étant rotatif autour dudit premier axe.

15. Système de façonnage d’une buse en une plaque de buse pour une tête d’impression à jet d’encre, ledit système comprenant un substrat de plaque de buse, un ensemble, et une source d’un faisceau haute énergie comportant un premier axe s’étendant dans une première direction ; dans lequel l’ensemble comprend une première surface de réflexion faisant un angle avec ladite première direction, une deuxième surface de réflexion et une troisième surface de réflexion, lesdites première, deuxième et troisième surfaces de réflexion étant placées de façon fixe l’une par rapport à l’autre de telle sorte que ledit faisceau haute énergie est réfléchi par ladite première surface de réflexion vers ladite deuxième surface de réflexion et ladite troisième surface de réflexion, de façon à, en même temps, inverser ledit faisceau et à diriger ledit faisceau le long d’un second axe colinéaire avec ledit premier axe s’étendant dans une première direction ; ledit ensemble étant rotatif autour dudit premier axe, et ledit substrat de plaque de buse étant disposé partiellement à l’intérieur d’un trajet défini par ledit second axe et agencé de telle sorte que ledit faisceau est orienté vers et frappe en premier une face dudit substrat de plaque de buse dans laquelle une sortie de buse est façonnée, et dans lequel ladite sortie de buse est plus petite en taille qu’une entrée de buse façonnée dans une face opposée dudit substrat de plaque de buse.